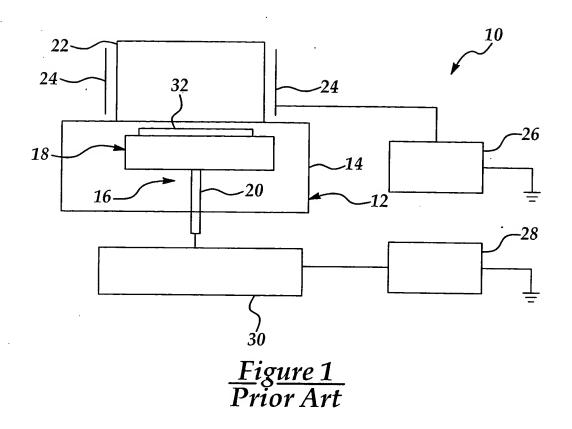
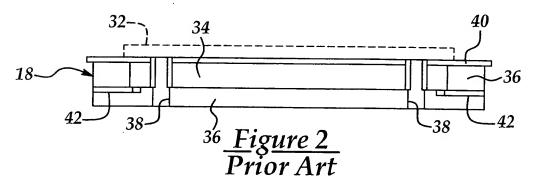
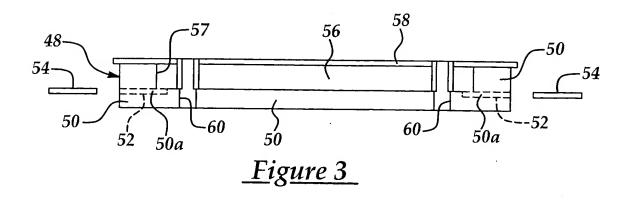
Inventor: WEN-CHI CHOU
Serial No.: To Be Assigned Filed: Herewith
Process For Reducing Particle Formation During Etching

Attorney Doc. No.: 67,200-1164







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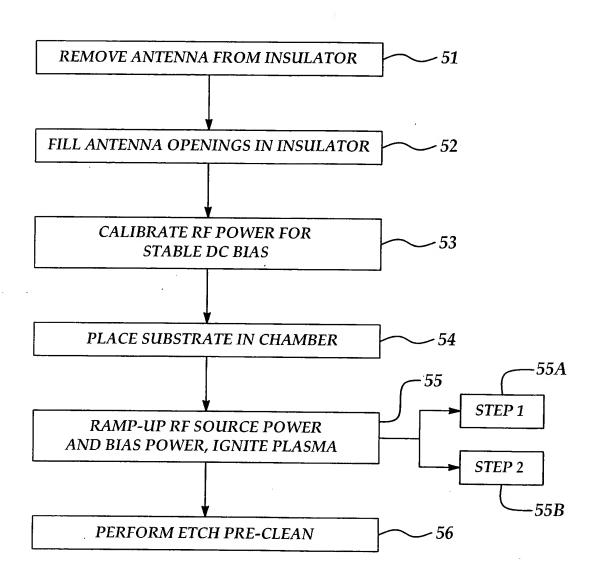


Figure 4